



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

February 4, 2008

In re the Application of

Koichi KANAYA et al.

Application No.: 10/565,653

\_

January 24, 2006

For:

Filed:

\_ .

Examiner:

Docket No.: 126247

Group Art Unit: 1762

K. CHEN

VAPOR DEPOSITION APPARATUS AND VAPOR DEPOSITION METHOD

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)
AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination (RCE) based on the above-identified patent application. The shortened statutory period for response having expired on <u>January 2, 2008</u>, an extension of time for a period of <u>one</u> month is hereby requested. Attached hereto is our Check No. <u>201992</u> in the amount of \$120.00 pursuant to 37 CFR §1.17.

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted

William P. Berridge Registration No. 30,024

Stephen P. Catlin Registration No. 36,101

WPB:SPC/ccs

OLIFF & BERRIDGE, PLC P.O. Box 320850 Alexandria, Virginia 22320-4850 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

CS/CE/SERR DELLERANT CRESSERV INSPESSOR

02 FC:1251

122.33 OP